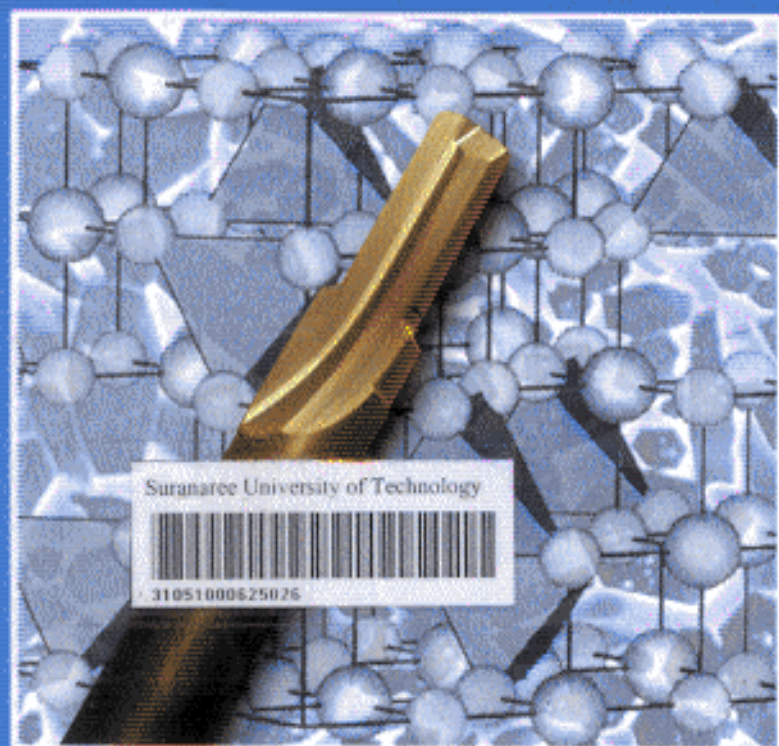


Handbook of Ceramic Hard Materials

Edited by Ralf Riedel

Volume 1



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